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Atty. Dkt. No. 039262-0153

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tadahiro OHMI et al.
Title: SHOWER PLATE, PLASMA PROCESSING APPARATUS,
AND PRODUCT MANUFACTURING METHOD
Appl. No.: 10/584,340
International Filing Date: 9/24/2004
371(c) Date: 8/02/2006
Examiner: Keath T. Chen
Art Unit: 1792
Confirmation Number: 2005

AMENDMENT AND REPLY UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Final Office Action dated January 14, 2009, concerning the above-referenced patent application.

Applicants have included payment for a three-month extension of time to make this response timely.

Listing of Claims begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: